GCM Series Specification and Test Methods

No.	AEC-Q200 Test Item		Specifications		AEC-Q200 Test Method					
			Temperature Compensating Type	High Dielectric Type	ALC-0200 Test Method					
1	Pre-and Po			_						
	High Temperature Exposure (Storage)		The measured and observed ch specifications in the following ta							
		Appearance	No marking defects							
2		Capacitance Change	Within ±2.5% or ±0.25pF (Whichever is larger)	Within ±10.0%	Sit the capacitor for 1000±12 hours at 150±3°C.			sit for 24±2		
		Q/D.F.	30pFmin.: Q≧1000 30pFmax.: Q≥400+20C C: Nominal Capacitance (pF)	*1 W.V.: 25Vmin.: 0.03 max. W.V.: 16V: 0.05 max.	hours at room temperature, then measure.	measure.				
		I.R.	More than 10,000M Ω or 500 Ω · (Whichever is smaller)	F *1						
	Temperat Cycle	ure	The measured and observed ch specifications in the following ta		under the same	e conditio	ns as (18	g jig in the same ma). Perform the 1000) cycles	
		Appearance	No marking defects					nts listed in the follo operature, then mea	•	
		Capacitance Change	Within ±2.5% or ±0.25pF (Whichever is larger)	Within ±10.0%	Step	1	2	3	4	
3		Onungo	30pFmin.: Q≧1000	*1	Temp. (°C)	-55+0/-3	Room Temp.	125+3/-0 (ΔC/R7/C7)	Room Temp.	
		Q/D.F.	30pFmax.: Q≧400+20C C: Nominal Capacitance (pF)	W.V.: 25Vmin.: 0.03 max. W.V.: 16V: 0.05 max.	Time (min.) 15±3 1		15±3	1		
		I.R.	More than 10,000M Ω or 500 Ω · (Whichever is smaller)	Initial measurement for high dielectric constant type Perform a heat treatment at 150 ^{±2} 0°C for one hour and then let sit for 24±2 hours at room temperature. Perform the initial measurement.						
4	Destructive Physical A		No defects or abnormalities		Per EIA-469					
	Moisture Resistance		The measured and observed characteristics should satisfy the specifications in the following table.		Apply the 24-hour heat (25 to 65°C) and humidity (80 to 98%) treatment shown below, 10 consecutive times.					
		Appearance	ce No marking defects		Let sit for 24±2 hours at room temperature, then measure.					
		Capacitance Change	Within ±3.0% or ±0.30pF (Whichever is larger)	Within ±12.5%	°C 90-98% 80-98% 90-98% 80-98% 9			midity -98%		
5		Q/D.F.	30pFmin.: Q≥350 10pF and over, 30pF and below: Q≥275+5/2 C 10pFmax.: Q≥200+10C C: Nominal Capacitance (pF)	*1 W.V.: 25Vmin.: 0.03 max. W.V.: 16V: 0.05 max.	65 60 65 50 45 91 40 92 93 94 94 94 94 94 94 94 94 94 94 94 94 94	+10.00	200			
		I.R.	More than $10,000M\Omega$ or 500Ω · (Whichever is smaller)	*1 F	Initial measurement Initial measurement One cycle 24 hours O1 2 3 4 5 6 7 8 9 1011 12131415161718192021222324 Hours			2324		
	Biased Humidity		The measured and observed ch specifications in the following ta							
		Appearance	No marking defects		Apply the rated voltage and 1.3+0.2/-0Vdc (add 6 at 85±3°C and 80 to 85% humidity for 1000±12 h Remove and let sit for 24±2 hours at room tempe					
6		Capacitance Change	Within ±3.0% or ±0.30pF (Whichever is larger)	Within ±12.5%			y for 1000±12 hour	S.		
J		Q/D.F.	30pF and over: Q≥200 30pF and below: Q≥100+ $\frac{10}{3}$ C C: Nominal Capacitance (pF)	*1 W.V.: 25Vmin.: 0.035 max. W.V.: 16V: 0.05 max.	measure.	,		,		
		I.R.	More than 1,000M Ω or $50\Omega \cdot F$ (Whichever is smaller)	*1						

^{*1:} The figure indicates typical specification. Please refer to individual specifications.

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Ne	AEC-Q200 Test Item		Specifications			AEC 0200 Toot Mothod		
No.			Temperature Compensating Type	High Dielectric Type		AEC-Q200 Test Method		
	Operational Life		The measured and observed characteristics should satisfy the specifications in the following table.		е			
		Appearance	No marking defects			Apply 200% of the rated voltage for 1000±12 hours at		
		Capacitance Change	Within ±3.0% or ±0.30pF (Whichever is larger)	Within ±12.5%		125±3°C. Let sit for 24±2 hours at room temperature, then measure. *2 The charge/discharge current is less than 50mA.		
7		Q/D.F.	30pFmin.: Q≥350 10pF and over, 30pF and below: Q≥275+½ C 10pFmax.: Q≥200+10C C: Nominal Capacitance (pF)	W.V.: 25Vmin.: 0.035 max. W.V.: 16V: 0.05 max.	*1	• Initial measurement for high dielectric constant type. Apply 200% of the rated DC voltage for one hour at the maximum operating temperature ±3°C. Remove and let sit for 24±2 hours at room temperature. Perform initial measurement. *2		
		I.R.	More than 1,000M Ω or $50\Omega \cdot F$ (Whichever is smaller)		*1			
8	External \	/isual	No defects or abnormalities			Visual inspection		
9	Physical [Dimension	Within the specified dimensions	i		Using calipers		
		Appearance No marking defects			Per MIL-STD-202 Method 215			
		Capacitance Change	Within the specified tolerance			Solvent 1: 1 part (by volume) of isopropyl alcohol 3 parts (by volume) of mineral spirits		
10	Resistance to Solvents	Q/D.F.	30pFmin.: Q≧1000 30pFmax.: Q≥400+20C C: Nominal Capacitance (pF)	W.V.: 25Vmin.: 0.025 max. W.V.: 16V: 0.035 max.	*1	Solvent 2: Terpene defluxer Solvent 3: 42 parts (by volume) of water 1 part (by volume) of propylene glycol		
		I.R.	More than 10,000M Ω or 500 Ω · (Whichever is smaller)	F	*1	monomethyl ether 1 part (by volume) of monoethanolamine		
		Appearance	No marking defects					
	Mechanical Shock	Capacitance Change	Within the specified tolerance			Three shocks in each direction should be applied along 3		
11		Q/D.F.	30pFmin.: Q≧1000 30pFmax.: Q≧400+20C C: Nominal Capacitance (pF)	W.V.: 25Vmin.: 0.025 max. W.V.: 16V: 0.035 max.	*1	mutually perpendicular axes of the test specimen (18 shocks). The specified test pulse should be Half-sine and should have a duration: 0.5ms, peak value: 1500g and velocity change: 4.7m/s		
		I.R.	More than 10,000M Ω or 500 Ω · (Whichever is smaller)	F	*1			
		Appearance	No defects or abnormalities			Solder the capacitor to the test jig (glass epoxy board) in the		
		Capacitance Change	Within the specified tolerance			same manner and under the same conditions as (19). The capacitor should be subjected to a simple harmonic motion		
12	Vibration	Q/D.F.	30pFmin.: Q≧1000 30pFmax.: Q≧400+20C C: Nominal Capacitance (pF)	W.V.: 25Vmin.: 0.025 max. W.V.: 16V: 0.035 max.	*1	having a total amplitude of 1.5mm, the frequency being varied uniformly between the approximate limits of 10 and 2000Hz. The frequency range, from 10 to 2000Hz and return to 10Hz, should be traversed in approximately 20 minutes. This motion should be		
		I.R.	More than 10,000M Ω or 500 Ω · (Whichever is smaller)	F	*1	applied for 12 items in each 3 mutually perpendicular directions (total of 36 times).		
	Resistand Soldering		The measured and observed characteristics should satisfy the specifications in the following table.		е			
		Appearance	No marking defects	rking defects		Immerse the capacitor in a eutectic solder solution at 260±5°C for 10±1 seconds. Let sit at room temperature for 24±2 hours, ther		
13		Capacitance Change	Within the specified tolerance			measure.		
13		Q/D.F.	30pFmin.: Q≥1000 30pFmax.: Q≥400+20C C: Nominal Capacitance (pF)	W.V.: 25Vmin.: 0.025 max. W.V.: 16V: 0.035 max.	*1	 Initial measurement for high dielectric constant type Perform a heat treatment at 150^{±0}/₁₀°C for one hour and then le sit for 24±2 hours at room temperature. Perform the initial measurement. 		
		I.R.	More than 10,000M Ω or 500 Ω · (Whichever is smaller)	F	*1	Total are minum measurement.		

^{*1:} The figure indicates typical specification. Please refer to individual specifications.

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^{*2:} Some of the parts are applicable in rated voltage x 150%. Please refer to individual specifications.

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No.		AEC-Q200 Specifications		AEC-Q200 Test Method					
10.	Test Item		Temperature Compensating Type	High Dielectric Type	ALO Q200 Test Method				
	Thermal Shock		The measured and observed characteristics should satisfy the specifications in the following table.		Fix the capacitor to the supporting jig in the same manner and under the same conditions as (18). Perform the 300 cycles				
		Appearance	No marking defects		according to the two heat treatments listed in the fo (Maximum transfer time is 20 seconds). Let sit for 24		•		
		Capacitance Change	Within ±2.5% or ±0.25pF (Whichever is larger)	Within ±10.0%	room temperature, the		2		
14		Q/D.F.	30pF min.: Q≧1000 30pF max.: Q≧400+20C C: Nominal Capacitance (pF)	*1 W.V.: 25Vmin.: 0.025 max. W.V.: 16V: 0.035 max.	Temp. (°C) -55- Time (min.) 15	+0/-3 125+3/-0 i±3	(5C, C7, R7) 15±3		
		I.R.	More than 10,000M Ω or 500 Ω · F (Whichever is smaller)		• Initial measurement for high dielectric constant type Perform a heat treatment at 150 ⁺⁰ ₋₁₀ °C for one hour and then let sit for 24±2 hours at room temperature. Perform the initial measurement.				
		Appearance	No marking defects						
		Capacitance Change	Within the specified tolerance						
15	ESD	Q/D.F.	30pF min.: Q≧1000 30pF max.: Q≥400+20C C: Nominal Capacitance (pF)	*1 W.V.: 25Vmin.: 0.025 max. W.V.: 16V: 0.035 max.	Per AEC-Q200-002				
		I.R.	More than 10,000M Ω or 500 Ω · (Whichever is smaller)	F *1					
16	Solderab	ility	95% of the terminations is to be soldered evenly and continuously.		 (a) Preheat at 155°C for 4 hours. After preheating, immerse the capacitor in a solution of ethanol (JIS-K-8101) and rosin (JIS K-5902) (25% rosin in weight proportion). Immerse in eutectic solder solution for 5+0/-0.5 seconds at 235±5°C. (b) Should be placed into steam aging for 8 hours±15 minutes. After preheating, immerse the capacitor in a solution of ethanol (JIS-K-8101) and rosin (JIS-K-5902) (25% rosin in weight proportion). Immerse in eutectic solder solution for 5+0/-0.5 seconds at 235±5°C. 				
				(c) Should be placed into steam aging for 8 hours±15 minutes. After preheating, immerse the capacitor in a solution of ethanol (JIS-K-8101) and rosin (JIS-K-5902) (25% rosin in weight proportion). Immerse in eutectic solder solution for 12 ±5 seconds at 260±5°C.					
		Appearance No defects or abnormalities		Visual inspection.					
		Capacitance Change	Within the specified tolerance		The capacitance/Q/D. frequency and voltage (1) Temperature Com	shown in the table.			
17	Electrical Characteri- zation	Q/D.F.	30pF min.: Q≧1000 30pF max.: Q≧400+20C C: Nominal Capacitance (pF)	*1 W.V.: 25V min.: 0.025 max. W.V.: 16V: 0.035 max	Capacitance C≤1000pF C>1000pF (2) High Dielectric Typ Capacitance C≤10μF	Frequency 1±0.1MHz 1±0.1kHz	Voltage 0.5 to 5Vrms 1±0.2Vrms Voltage 1±0.2Vrms 0.5±0.1Vrms		
		I.R.	25°C More than 100,000M Ω or 1,000 Ω · F (Whichever is smaller) Max. Operating Temperature125°C More than 10,000M Ω or 100 Ω · F (Whichever is smaller)	*1 25° C More than 10,000M Ω or 500 Ω · F (Whichever is smaller) Max. Operating Temperature125°C More than 1,000M Ω or 10 Ω · F (Whichever is smaller)		istance should be measured with a DC voltage rated voltage at 25°C and 125°C and within 2			
		Dielectric Strength	No failure		No failure should be observed when 250% of the rated voltage is applied between the terminations for 1 to 5 seconds, provided the charge/discharge current is less than 50mA.				

^{*1:} The figure indicates typical specification. Please refer to individual specifications.

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No.	AEC- Test		Specifi		AEC-Q200 Test Method				
			Temperature Compensating Type	High Dielectric Type					
		Appearance	No marking defects		Solder the capacito				
		Capacitance Change	Within ±5.0% or ±0.5pF (Whichever is larger)	Within ±10.0%	Fig. 1 using a eutectic solder. Then apply a for shown in Fig. 2 for 5±1sec. The soldering should reflow method and should be conducted with		soldering shoul	d be done by the	
			30pF min.: Q≧1000	*1	soldering is uniforr	m and free of o	defects such as	heat shock.	
		Q/D.F.	30pF max.: Q≥400+20C C: Nominal Capacitance (pF)	W.V.: 25Vmin.: 0.025 max. W.V.: 16V: 0.035 max.	Туре	a	b	С	
			C. Nominal Capacitance (pr.)	vv.v 10 v. 0.000 max.	GCM03	0.3	0.9	0.3	
					GCM15 GCM18	0.5 0.6	1.5 2.2	0.6	
					GCM21	0.8	3.0	1.3	
40	Board			b	GCM31	2.0	4.4	1.7	
18	Flex				GCM32	2.0	4.4	2.6	
			*1	9		444		(in mm)	
		. 5	More than $10,000M\Omega$ or $500\Omega \cdot F$	a		20	Pressunzing speed: 1.0mm/s	sec	
		I.R.	(Whichever is smaller)	100	R	4	Pressurize		
				t: 1.6mm (GCM03/15: 0.8mm)	· 6		7		
				,			† Flexure: ≦2		
				Fig. 1		apacitance meter	(High Dielectric Flexure: ≤3	Type)	
					- 4 :	5 45	(Temperature Compensating	Tyne)	
						Fig		Турс)	
		Annogrango	No marking defects		Coldor the consoit			hoord) shown in	
		Appearance	No marking defects		Solder the capacitor to the test jig (glass epoxy board) shown in Fig. 3 using a eutectic solder. Then apply *18N force in parallel				
		Capacitance Change	Within the specified tolerance		with the test jig for				
		Change			The soldering shou			•	
		Q/D.F.	30pF min.: Q≧1000 30pF max.: Q≧400+20C	*1 W.V.: 25Vmin.: 0.025 max.	reflow method and soldering is uniforn				
			C: Nominal Capacitance (pF)	W.V.: 16V: 0.035 max.	*2N (GCM03/15)	ii and nee or c	ielecis sucii as	ricat shock.	
			. , ,		Type	а	b	С	
					GCM03	0.3	0.9	0.3	
					GCM15	0.4	1.5	0.5	
					GCM18 GCM21	1.0	3.0 4.0	1.2 1.65	
19	Terminal Strength	I.R.			GCM31	2.2	5.0	2.0	
	Suengui				GCM32	2.2	5.0	2.9	
			More than 10,000M Ω or 500 Ω · F		Ç (in mm				
			(Whichever is smaller)						
					ا م				
					(t=1.6mm GCM03/15: 0.8mm				
					Baked electrode or copper foil				
					Fig. 3				
				Place the capacitor in the beam load fixture as Fig. 4. Apply a force.					
					<pre>< Chip Length: 2.5mm max. ></pre>				
						I			
			The chip endure following force.				7/		
			< Chip L dimension: 2.5mm m	ax. >		0	r 		
20	Door !	nd Took	Chip thickness > 0.5mm rai		Speed supplied the	e Stress Load	U.5mm / sec.		
20	Beam Loa	au rest	Chip thickness ≤ 0.5mm rate < Chip L dimension: 3.2mm m		< Chip Length: 3.2	mm min. >			
			Chip thickness < 1.25mm rank: 15N						
			Chip thickness ≥ 1.25mm ra	ank: 54.5N					
					Speed supplied the Stress Load: 2.5mm / sec.				
						Fig. 4			
				FIG. 4					

^{*1:} The figure indicates typical specification. Please refer to individual specifications.



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		AEC-Q200 Test Item		Specifi	cations	AEC-Q200 Test Method		
N	lo.			Temperature Compensating Type	High Dielectric Type			
			Capacitance Change	Within the specified tolerance (Table A)	C7: Within ±22% (-55°C to +125°C) R7: Within ±15% (-55°C to +125°C)	The capacitance change should be measured after 5 min. at each specified temperature stage. (1) Temperature Compensating Type The temperature coefficient is determined using the capacitance.		
			Temperature Coefficient	Within the specified tolerance (Table A)		measured in step 3 as a reference. When cycling the temperature sequentially from step1 through 5 (ΔC: +25°C to +125°C: other temp. coeffs.: +25°C to +85°C) the capacitance		
			Capacitance Drift	Within ±0.2% or ±0.05 pF (Whichever is larger) * Do not apply to 1X/25V		should be within the specified tolerance for the temperature coefficient and capacitance change as shown in Table A. The capacitance drift is calculated by dividing the differences between the maximum and minimum measured values in step 1, 3 and 5 by the capacitance value in step 3. Step		

^{*1:} The figure indicates typical specification. Please refer to individual specifications.

Table A

		Capacitance Change from 25°C (%)				5)		
Char.	Nominal Values (ppm/°C) Note1	-[55	-3	30	-1	10	
		Max.	Min.	Max.	Min.	Max.	Min.	
5C	0±30	0.58	-0.24	0.40	-0.17	0.25	-0.11	

Note 1: Nominal values denote the temperature coefficient within a range of 25°C to 125°C (for 5C).